

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional) 09780001AA	Application Number unknown
Applicant(s) Masahiko Ishida et al.	
Filing Date March 22, 2006	Group Art Unit unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2003-238123	08.27.2003	NEC CORP.	Int. Cl		✓	
		2003-017508	17.01.2003	NEC CORP.	Int. Cl		✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	J. Fujita et al. Graphitization of FE-doped amorphous carbon pillars grown by focused-ion-beam-induced chemical-vapor deposition, Journal of Vacuum Science & Technology B, second series, volume 20, number 6, 11/2002; pages 2686-2689
	Yoshikazu Homma et al. Growth of suspended carbon nanotube networks on 100-nm-scale silicon pillars; A Applied Physics Letters, volume 81, number 12; 09.16.2002; pages 2261-2263

EXAMINER	DATE CONSIDERED
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Selzo Kinoshita et al., "Ichi Seigyo Seicho Carbon Nanotube ni yoru Shitsuen Coulomb Blockade", The Institute of Electronics, Information and Communication Engineers Gijutsu Kenkyu Hokoku, 29 January, 2002 (29.01.02), Vol.101, No.618, pages 47 to 52

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